

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

PATENT

Applicants:	Yoshitaka Nishio, et al.	Atty. Docket No.:	49288.3500
Serial No.:	10/598,878	Examiner	Ghassem Alie
Date Filed:	May 21, 2007	Group Art Unit:	3724
Title:	SUBSTRATE DIVIDING SYSTEM, SUBSTRATE MANUFACTURING EQUIPMENT, SUBSTRATE SCRIBING METHOD AND SUBSTRATE DIVIDING METHOD	Confirmation No.:	1712

AMENDMENT AND REPLY

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the Office Action mailed on November 13, 2009, of which this Reply is filed within the one month shortened statutory period for reply, please consider the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.